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RESPONSE UNDER 37 C.F.R. § 1.116
EXPEDITED PROCEDURE REQUESTED
EXAMINING GROUP 2822
PATENT
Attorney Docket No. 04329.2335-01000

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
Tokuhisa OHIWA et al.) Group Art Unit: 2822
Application No.: 10/824,537) Examiner: AU, Bac H.
Filed: April 15, 2004)
For: METHOD OF MANUFACTURING) Confirmation No.: 6543
SEMICONDUCTOR DEVICE)

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

AMENDMENT AFTER FINAL

In reply to the Final Office Action mailed October 19, 2006, the period for response extending through January 19, 2007, and pursuant to 37 C.F.R. § 1.116, Applicants propose that this application be amended as follows:

Amendments to the Claims are reflected in the listing of claims in this paper.

Remarks follow the amendment section of this paper.